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Application/Control No.	Applicant(s)/Patent under Reexamination
10/537,574	LUO, SIFEN
Examiner	Art Unit
Steven J. Mottola	2817

SEARCHED				
Class	Subclass	Date	Examiner	
330	288	2/20/2007		
	296			
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NO (INCLUDING SEARCH	TES I STRATEGY	<u>')</u>
	DATE	EXMR
EAST see printout	2/20/2007	9
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